IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent of: Weimer		Patent Number: 6838121	
Serial Number: 09/852992		Issue Date: 01/04/2005	
Validati	§	2000 2000 02, 02, 2000	
05/10/2001	8	Confirmation Number: 5859	
	§		
System and Method for Controlling	§	Attorney Docket Number: 40232.78	
Deposition Parameters in Producing a	§	-	
Surface to Tune the Surface's Plasmon	§		
Resonance Wavelength	§		
	Number: 09/852992 05/10/2001 System and Method for Controlling Deposition Parameters in Producing a Surface to Tune the Surface's Plasmon	Number: 09/852992 \$ S 05/10/2001 \$ System and Method for Controlling \$ Deposition Parameters in Producing a Surface to Tune the Surface's Plasmon \$	

REVOCATION OF POWER OF ATTORNEY WITH NEW POWER OF ATTORNEY AND CHANGE OF CORRESPONDENCE ADDRESS BY ASSIGNEE OF ENTIRE INTEREST INCLUDING CERTIFICATION FOR TAKING ACTION BY ASSIGNEE UNDER 37 CFR 3.73(b)

As a representative of the Assignee, Zyvex Labs, LLC, a Limited Liability Company,

	T		*** **	<u> </u>	
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as our attorneys and/or agents to prosecute this patent and transact all business in the Patent and Trademark Office connected therewith.

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The undersigned representative of the assignee certifies that Zyvex Labs, LLC is the assignee of the entire right, title and interest in the above-identified patent by virtue of a chain of title from the inventor(s) of the above-identified patent to the assignee as shown below:

From: Wayne A. Weimer To: Zyvex Corporation

I hereby appoint:

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The undersigned is authorized to act on behalf of the Assignee.

Zyvex Labs, LLC

7-2-07

By:

Timothy M. Gilmore, CFO